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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANTS: Erik Cardelius et al CONFIRMATION NO.: 9603
SERIAL NO.: 10/790,587 GROUP ART UNIT: 2857
FILED: March 1, 2004
TITLE: "APPARATUS AND METHOD FOR CALIBRATING A
RESISTANCE THERMOMETER AND GAS ANALYZER
EMPLOYING SAME"

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the following documents be made during the course of examination of the above-referenced application for United States Letters Patent.

AA United States Patent No. 4,795,884
AL United Kingdom Application 2 256 051
AM Russian Patent 857 744
AU U.S. Patent Application Publication 2003/0136200

EXPLANATION OF RELEVANCE

The above references were cited in a Search Report rendered by the Swedish Patent Office in connection with the examination of the counterpart Swedish Application. All of the references were cited in Category "A" as general background information. A copy of the Swedish Search Report is submitted herewith.

Copies of each of the above references together with Form 1449 are submitted herewith. For the references that are in English, no further commentary concerning their teachings is necessary. A translation of Reference AM is not readily available to the Applicants, however, an English language Abstract is attached thereto.

As of the date of mailing of this Information Disclosure Statement, a first Office Action on the merits has not been received in connection with this application. This Information Disclosure Statement is therefore in compliance with 37 C.F.R. §1.97(b)(3), and no fee is necessary.

All claims of the application are submitted to be patentable over the teachings of the above references, taken singly or in combination. Early consideration of the application is therefore respectfully requested.

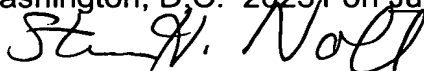
Submitted by,

 (Reg. 28,982)

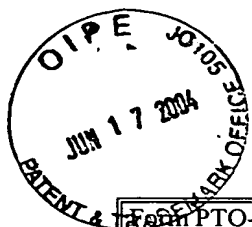
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on June 14, 2004.



STEVEN H. NOLL



INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)					Docket No. P04,0024		Serial No. 10/790,587	
					Applicant Erik Cardelius et al			
					Filing Date March 1, 2004		Group Art Unit 2857	
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate	
✓	AA	4,795,884	01/03/89	Carroll				
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
✓	AL	2 256 051	11/25/92	United Kingdom				
✓	AM	857 744	08/23/81	Russia				
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AT							
	AU	U. S. Patent Application Publication 2003/0136200 July 24, 2003						
	AV							
	AW							
Examiner			Date Considered					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								